

ELECTRONIC INFORMATION DISCLOSURE STATEMENT

Electronic Version v18

Stylesheet Version v18.0

Title of Invention

SEMICONDUCTOR DEVICE AND FABRICATION PROCESS
THEREFOR

Application Number :

Confirmation Number:

First Named Applicant: Lloyd Burrell

Attorney Docket Number: FIS920030011US1

Art Unit:

Examiner:

Search string: (5391516 or 6350667 or 5523626 or 20020068385 or 20010051426).pn

US Patent Documents

Note: Applicant is not required to submit a paper copy of cited US Patent Documents

init	Cite.No.	Patent No.	Date	Patentee	Kind	Class	Subclass
P.M	1	5391516	1995-02-21	WOJNAROWSKI, ET AL.			
A.M	2	6350667	2002-02-26	CHEN, ET AL.			
A.M	3	5523626	1996-06-04	HAYASHI, ET AL.			

US Published Applications

Note: Applicant is not required to submit a paper copy of cited US Published Applications

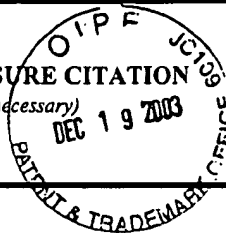
init	Cite.No.	Pub. No.	Date	Applicant	Kind	Class	Subclass
A.M	1	20020068385	2002-06-06	MA, ET AL.			
A.M	2	20010051426	2001-12-13	POZDER, ET AL.			

Signature

Examiner Name	Date
ANH D. MAI	10/05/04

INFORMATION DISCLOSURE CITATION

(Use several sheets if necessary)



Docket Number (Optional)

FIS920030011US1

Application Number

10/605,369

Applicant(s)

LLOYD BURELL, ET AL.

Filing Date

10/25/03

Group Art Unit

U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
A.M		6,242,078	6/05/01	Pommer et al.	428	290	
A.M		6,435,398	8/20/02	Hartfield et al.	228	103	

FOREIGN PATENT DOCUMENTS

	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO
P.M		JP0008821A2		JAPAN				

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

EXAMINER

ANH D. MAI

DATE CONSIDERED

10/05/04

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.